

Title (en)

INK JET HEAD SUBSTRATE, INK JET HEAD HAVING SAME AND MANUFACTURING METHOD FOR INK JET HEAD

Publication

EP 0389296 A3 19910403 (EN)

Application

EP 90303137 A 19900323

Priority

- JP 347990 A 19900112
- JP 7218389 A 19890324

Abstract (en)

[origin: EP0389296A2] An ink jet recording head substrate includes a supporting member (1), a plurality of electrothermal transducers having heat generating resistors (2a) and electrodes (3a, b) electrically connected to the heat generating resistors; and identification marks (4) for easy identification of each of the electrothermal transducers.

IPC 1-7

B41J 2/16

IPC 8 full level

B41J 2/16 (2006.01)

CPC (source: EP)

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Citation (search report)

- [A] US 4716421 A 19871229 - OZAWA KUNITAKA [JP], et al
- [A] US 4740800 A 19880426 - KYOSHIMA MASAYUKI [JP]
- [A] DE 3702643 A1 19870813 - TOSHIBA KAWASAKI KK [JP]
- [A] EP 0066835 A2 19821215 - SIEMENS AG [DE]

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Designated contracting state (EPC)

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DOCDB simple family (publication)

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